

Attorney Docket No. 1864 P 071

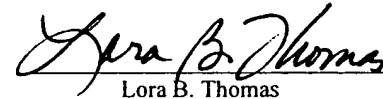


IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

JAN 22 2002
TC 3700 MAIL ROOM

CERTIFICATE OF MAILING

I hereby certify that this Information Disclosure Statement is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Box DD, Commissioner for Patents, Washington, D.C. 20231 on December 12, 2001.


Lora B. Thomas

Applicant: Peter V. Loeppert
and Sung Bok Lee

For: Raised Microstructure of Silicon
Based Device

Serial No.: 09/910,110

Filed: July 20, 2001

Examiner: Not Yet Assigned

Art Unit: 3729

**TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT
BEFORE MAILING DATE OF EITHER A FINAL ACTION
OR NOTICE OF ALLOWANCE (37 C.F.R. § 1.97(c))**

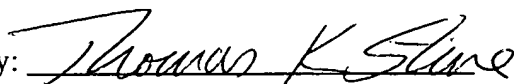
BOX DD
Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

Applicant submits herewith Form PTO-1449, "Information Disclosure Statement," and a copy of the references listed thereon.

Since this Statement is being filed before the mailing date of the first Official Action on the merits, no certification or fee is necessary. The Commissioner is hereby authorized to charge payment of any deficit in these fees to Deposit Account No. 23-0280. A duplicate copy of this sheet is enclosed for that purpose.

Respectfully submitted,

By: 
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